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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on December 2, 2005.

Er Witt  
Attorney for Applicants

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/782,533 Confirmation No.: 3242  
Applicant : An Shih et al.  
Title : THIN FILM TRANSISTOR HAVING LDD  
REGION AND PROCESS FOR PRODUCING  
SAME  
Filed : February 19, 2004  
TC/A.U. : 2826  
Examiner : Scott R. Wilson  
Docket No. : 3304.2.120  
Customer No. : 21552

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Dear Sir:

This paper is filed in response to the Office Action of September 12, 2005.

**Remarks/Arguments** begin on page 2 of this paper.